## IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: S. NAGAHAMA et al. Conf.: Unassigned

Appl. No.: NEW - Div. of U.S. Group: Unassigned

Appl. 09/714,143

Filed: June 24, 2003 Examiner: UNASSIGNED

For: NITRIDE SEMICONDUCTOR DEVICE

# INFORMATION DISCLOSURE STATEMENT (SUBMISSION WITH CONTINUATION-IN-PART OR

RULE 1.53(b) CONTINUATION OR DIVISIONAL APPLICATION)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 June 24, 2003

Sir:

Pursuant to 37 C.F.R. §§ 1.97 and 1.98, applicant(s) hereby submit(s) an Information Disclosure Statement for consideration by the Examiner.

## I. LIST OF PATENTS, PUBLICATIONS OR OTHER INFORMATION

The patents, publications, or other information submitted for consideration by the Office are listed on the PTO-1449 form(s), attached hereto.

## II. REFERENCES PREVIOUSLY CITED OR SUBMITTED

Pursuant to 37 C.F.R. § 1.98(d), consideration of information listed on the PTO-1449 form(s) is requested since any patents, publications, or other information which are listed on the PTO-1449 form(s) but for which copies are not enclosed herewith, were previously cited by or submitted to the PTO in one of the following applications which has been relied upon for an earlier filing date under 35 U.S.C. § 120:

 U.S. Appl. No(s).
 U.S. Filing Date(s)

 09/714,143
 November 17, 2000

 09/004,925
 January 9, 1998

### III. FEES

This Information Disclosure Statement is being filed concurrent with the filing of a continuation-in-part, continuation, or divisional patent application; therefore, no fee is required.

If the Examiner has any questions concerning this IDS or requires a copy of any of the references cited but not provided, he/she is requested to contact the undersigned. If it is determined that this IDS has been filed under the wrong rule, the PTO is requested to consider this IDS under the proper rule and charge the appropriate fee to Deposit Account No. 02-2448.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fee required under 37 C.F.R. §§ 1.16 or 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

D. Richard Anderson, #40,439

DRA/CMV/jdm 0020-5123P P.O. Box 747 Falls Church, VA 22040-0747 (703) 205-8000

Attachment(s):  $\square$  PTO-1449(s)

□ References (1)

☐ Foreign Search Report

□ Other:

(Rev. 04/29/03)

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